

Application No. 10/518,197
Paper Dated: March 28, 2008
In Reply to USPTO Correspondence of September 28, 2007
Attorney Docket No. 1217-045623

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/518,197 Confirmation No. 5218
Applicants : Yasuo Nakamura et al.
Filed : December 16, 2004
Title : REACTION APPARATUS FOR PRODUCING
SILICON
Group Art Unit : 1743
Examiner : Lessanework T. Seifu
Customer No. : 28289

MAIL STOP AMENDMENT
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated September 28, 2007, Applicants submit the following amendments and remarks, along with a Petition for Extension of Time and relevant fee.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 5 of this paper.

I hereby certify that this correspondence is being electronically submitted to the United States Patent and Trademark Office on March 28, 2008.

03/28/2008 Florence P. Trevethan
Date Signature
Florence P. Trevethan
Typed Name of Person Signing Certificate